

FIG. 2

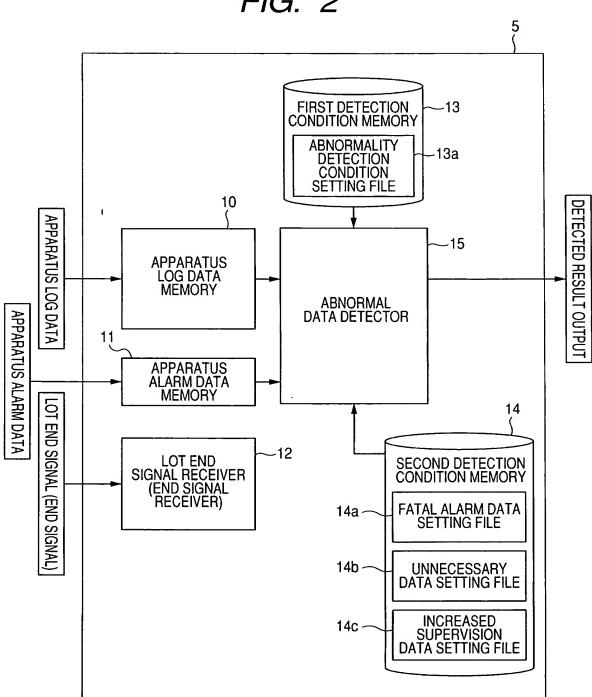


FIG. 3

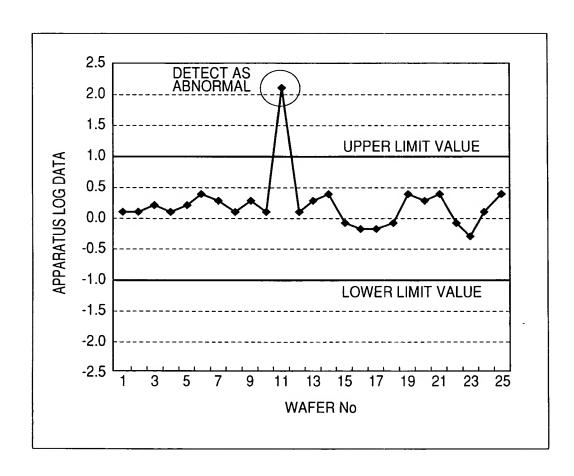


FIG. 4

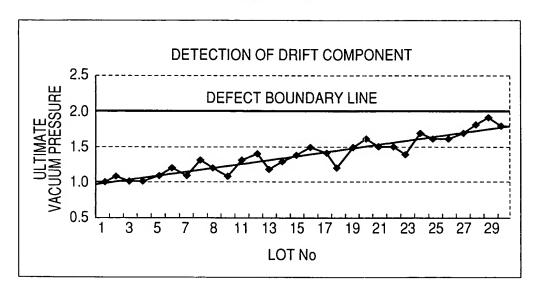


FIG. 5

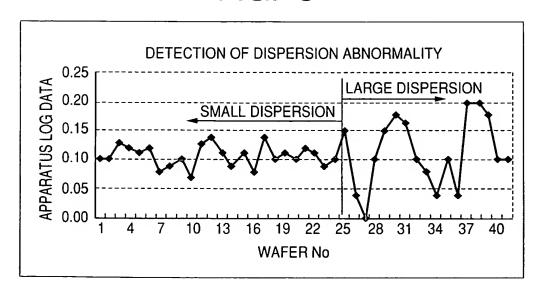
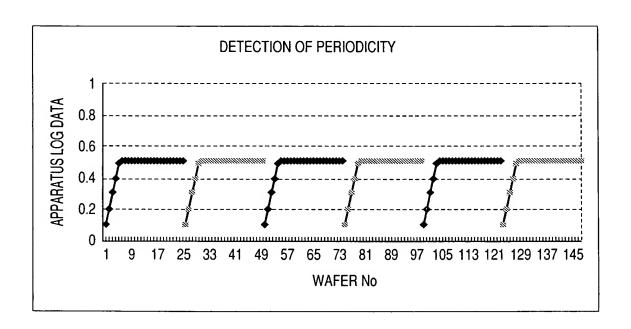
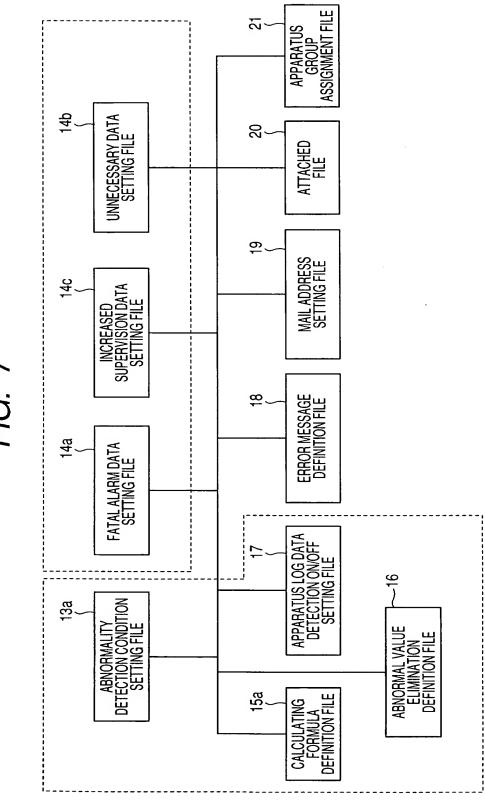


FIG. 6





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PORTION	APPARATUS LOG DATA	APPARATIOS SIDE NAME	G1	G2	G3	G4	G5	G6
APPARATUS LOG DATA SETTING PORTION	MAILING		ALL MEMBERS					
RATUS LOG	JO'	DISPLAY	NO	NO	NO	NO	NO	NO
APPA	PARAMETER SETTING	REFERENCE COLUMN						
	PROC NAM	ESS NE	Key	Key	Key	Key	Key	Key
	PROD NAM	UCT ME	Key	Key	Key	Key	Key	Key
	STEP ID	<u>.</u>						
KEY	CHAMBER							
SEARCH KEY	ATUS AE	SEARCH KEY	Key	Key	Key	Key	Key	Key
S	APPARATUS NAME	IATE SETTING SEARCH KEY	A	A	ω	8	A-I	A-KrF
	RECIPE No	ELIMINATE						
	REC	SEARCH FOR						
	S	2	-	2	ო	4	ည	ဖ

REI C	ERENCE OLUMN						
ORMALITY MENT	NORMAL						
WIDTH ABNO	JUDGMENT ON/OFF						
OWER DGMENT	LOWER THRESHOLD VALUE					0.01	0.01
IPPER AND LO	UPPER THRESHOLD VALUE					0.05	0.05
UPPI	JUDGMENT ON/OFF					NO	NO
BNORMALITY	σ COEFFICIENT	ε	3	8	3		
σ ABNORM JUDGME	JUDGMENT ON/OFF	NO	NO	NO	ON		
IMBER OF RCH DATA	MAXIMUM DATA NUMBER	25	25	25	25		
NUMBE	MINIMUM DATA NUMBER	3	3	3	8		
	REGISTERED DATE	2003/1/31	2003/1/31	2003/1/31	2003/1/31	2003/1/31	2003/1/31
	RESET FLAG DURING APPARATUS MAINTE- NANCE						
COMMON	ERROR ATTACHED MESSAGE FILE	101	101				
	ERROR MESSAGE	-	-	-	-	4	9
	IDGMENT AETHOD	THIN LOT	THIN LOT	ITHIN LOT	THIN LOT	NTINUOUS	NTINUOUS

FIG. 9

APPARATUS	SEMICON-	WAVE-		APPAR	RATUS GI	ROUPING	NAME	
NAME	SEMICON- DUCTOR MAKER	LENGTH	Α	В	A-I	A-KrF	B-I	B-KrF
F-01	Α	I LINE	0		0			
F-02	Α	I LINE	0		0			
F-03	Α	I LINE	0		0			
F-04	Α	I LINE	0		0			
F-05	Α	I LINE	0		0			
E-01	Α	KrF	0			0		
E-02	Α	KrF	0			0		
E-03	Α	KrF	0			0		
E-04	Α	KrF	0			0		
N-01	В	I LINE		0			0	
N-02	В	I LINE		0			0	
N-03	В	I LINE		0			0	
N-04	В	I LINE		0			0	
E-08	В	KrF		0				0
E-09	В	KrF		0				0
E-10	В	KrF		0				0
E-11	В	KrF		0				0
E-12	В	KrF		0				0

					A.	APPARATUS LOG DATA	OG DATA				
APPARATUS CODE	APPARATUS NAME	Ğ	G2	දි	G4	G5	95	25	68	69	G10
24042	F-01	NO	S	OFF	340	NO	NO	NO	NO	NO	NO
2404L	F-02	NO	NO	OFF	JH0	NO	NO	NO	NO	NO	ON
2404M	F-03	NO	8	OFF	J-JO	NO	NO	NO	NO	NO	NO
2404N	F-04	NO	8	OFF	OFF	8	NO	NO	NO	NO	NO
24040	F-05	NO	8	PF.	OFF	8	NO	NO	NO	NO	NO
2404H	E-01	OFF	OFF	No	NO	OFF	J-JO	JH0	OFF	OFF	OFF
2404D	E-02	OFF	OFF	NO	NO	OFF	J-JO	OFF	OFF	OFF	OFF
2404E	E-03	OFF	OFF	NO	NO	OFF	OFF	OFF	OFF	OFF	OFF

FIG. 11

KIND OF APPARATUS LOG DATA	PRODUCT	PROCESS	APPARATUS	LOWER LIMIT	UPPER LIMIT
GLOBAL ALIGNMENT MEASUREMENT	α	1	#1	0.1	0.5
SHIFT X		2		0	0.8
		3		0.4	1
		4		0.8	1.2
		1	#2	0.2	0.6
		2		-0.5	-0.3
	:	3		0.1	0.8
		4		1.2	1.8

FIG. 12

KIND OF APPARATUS	PRODUCT	PROCESS	APPARATUS	COEFFICIENT
LOG DATA	NAME	NAME	NAME	
GLOBAL ALIGNMENT MEASUREMENT SHIFT X	key	key	key	3

HEADER OF APPARATUS LOG DATA

PRODUCT NAME: α

PROCESS NAME: 3

APPARATUS NAME: #1

LOT No: G0001

RECIPE No: RESIST COATING

No	CONTENT OF DETECTION ITEM	CALCULATING FORMULA	PARAMETER P1 FOR CALCULATION	PARAMETER P2 FOR CALCULATION	PARAMETER PARAMETER PARAMETER PARAMETER PA FOR PA FOR PA FOR PA FOR CALCULATION CALCULATION	PARAMETER PARAMETER PARAMETER PARAMETER P1 FOR P2 FOR P3 FOR P4 FOR CALCULATION CALCULATION
-	PARAMETER Z	(Ch1+Ch4)/2-(Ch2+Ch5)/2	Ch1	Ch2	Ch4	Ch5

ERROR No	SUMMARY DISPLAY	CONTENT OF ERROR MESSAGE
-	ALIGNMENT ABNORMALITY	THERE IS AN ABNORMALITY IN AN ALIGNMENT MEASUREMENT RESULT. SINCE AN ALIGNMENT SHIFT MAY OCCUR, INSPECT ALIGNMENT OF AN ABNORMAL WAFER. SEND OUT WHEN THERE IS NO ABNORMALITY IN THE ALIGNMENT INSPECTION RESULT. FREQUENT OCCURRENCE REQUIRES A NOTIFICATION TO (MANUFACTURING TECHNOLOGY SECTION).
2	ALIGNMENT ABNORMALITY	THERE IS AN ABNORMALITY IN A BLC MEASUREMENT VALUE. SINCE AN ALIGNMENT SHIFT MAY OCCUR, INSPECT ALIGNMENT OF AN ABNORMAL LOT. WHEN A SHUTDOWN OR INITIALIZATION IS CAUSED DURING A PROCESS OF A LOT, INSPECT WAFERS BEFORE AND AFTER THAT. SEND OUT WHEN THERE IS NO ABNORMALITY IN THE ALIGNMENT INSPECTION RESULT. FREQUENT OCCURRENCE REQUIRES A NOTIFICATION TO (MANUFACTURING TECHNOLOGY SECTION).
က	FOCUS ABNORMALITY	THERE IS AN ABNORMALITY IN A FOCUS MEASUREMENT VALUE. SINCE A FOCUS SHIFT MAY OCCUR, CARRY OUT A DIMENSION INSPECTION AND FOCUS QC. WHEN A SHUTDOWN OR INITIALIZATION IS CAUSED DURING A PROCESS OF A LOT, INSPECT WAFERS BEFORE AND AFTER THAT. WRITE IN APPARATUS QC DATA IN A COMMENT COLUMN. FREQUENT OCCURRENCE REQUIRES A NOTIFICATION TO (MANUFACTURING TECHNOLOGY SECTION).

FIG. 16

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		Y DIRECTION	SPECIFICATION MEASUREMENT JUDGMEN RESULT			RETURN
UREMEN			JUDGMENT RESULT	:		
NMENT MEASI		X DIRECTION	SPECIFICATION MEASUREMENT JUDGMENT RESULT			
OUT AN ALIGI JRN.		×	SPECIFICATION			
ARRY (UPPER	LOWER	
A STEPPER MEASUREMENT ABNORMALITY OCCURRED. SINCE AN OFF-SPECIFICATION ALIGNMENT MAY OCCUR, CARRY OUT AN ALIGNMENT MEASUREMENT. WRITE IN A CONCERNED PRODUCT IN A TABLE BELOW AND RETURN.		CONTENT OF	OPERATION	IMPLEMENTATION UPPER	OF ALIGINMENT INSPECTION	
EMENT ABNORMAL FICATION ALIGNMI VED PRODUCT IN A	-	DETECTION	ITEM	GLOBAL ALIGNMENT	MEASUREMENT DATA	
R MEASUR! OFF-SPECII A CONCERN	ATTACHED FILE No: 101	WAFER	2			
A STEPPE SINCE AN WRITE IN	ATTACHED	LOT	0 N			
				_		

No	FATAL ALARM DATA	INPUTTER	TERMINAL DISPLAY ON/OFF	MAIL ADDRESS	ALARM CONTENT	CONTENT OF ENGINEER'S INSTRUCTION
1	A0001		ON	ENGINEER		
2	A0002		ON	ENGINEER		
3	A0003		ON	ENGINEER		
4	B0***		ON	ENGINEER		

FIG. 18

No	UNNECESSARY DATA	INPUTTER
1	X0001	
2	X0002	
3	Y00**	

No	INCREASED SUPERVISION DATA	SUPERVISION TIME	NUMBER OF TIMES	INPUTTER	TERMINAL DISPLAY ON/OFF	MAILING ADDRESS	CONTENT OF ENGINEER'S INSTRUCTION
1	Z0001	2	10		ON	ENGINEER	
2	Z0002	2	5		ON	ENGINEER	
3	DEFAULT	1	10		ON	ENGINEER	

-	ELEMENT	IMPLA			
	START TIME	2003/1/10 10:10			
	COMPLETION TIME	2003/1/10 11:00			
	PRODUCT NAME	А			
	PROCESS NAME	×			,
	RECIPE NAME	A-X			
	APPARATUS NAME	HE-01			
	LOT No	A0001			
	CHAMBER NAME				
	STEP NAME				
	APPARATUS ERROR	YES			
	ERROR MESSAGE No	CONTENT OF ERROR MESSAGE	AGE	CHECK FILE	CONCERNED PRODUCT
	-	A PRESSURE ABNORMALITY CONFIRM A CONTENT OF A	A PRESSURE ABNORMALITY IS DETECTED. CONFIRM A CONTENT OF AN ATTACHED FILE AND SEND OUT THE LOT.	NONE	OPEN
	2	AN INJECTION CURRENT AF	AN INJECTION CURRENT ABNORMALITY IS DETECTED. CONFIRM A CONTENT OF AN ATTACHED FILE AND SEND OUT THE LOT.	YES	OPEN

APPARATUS E	RROR FILE	
APPARATUS ERROR	OCCURRENCE TIME PERIOD	15:30
	WAFER No	10
	CODE	* * * * - * * * *
	CONTENT	VACUUM PRESSURE ABNORMALITY
APPARATUS ERROR	OCCURRENCE TIME PERIOD	15:40
	WAFER No	15
	CODE	* * * * - * * * *
	CONTENT	VACUUM PRESSURE ABNORMALITY

FIG. 22

LOT No	WAFER No	DETECTION ITEM	DETECTION METHOD
A001	1	VACUUM PRESSURE	UPPER AND LOWER LIMIT VALUES
A001	5, 10	INJECTION CURRENT	WIDTH JUDGMENT

FIG. 23

No	CONTENT OF CONFIRMATION	MA SPE	NAGEME CIFICAT	:NT ION	MANAGEMENT	JUDGMENT
		UNIT	LOWER LIMIT	UPPER LIMIT	VALUE	JODGINENT
1	VACUUM OF BEAM LINE (NO LOAD)	E-6Torr	_	1.00	0.56	OK
2	VACUUM OF BEAM LINE (WITH GATE VALVE OF CRYO CLOSED)	E-6Torr	0.11	_		
3	VACUUM OF ANALYZER (WITH BEAM GATE IN UNDER NO LOAD)	E-6Torr	-	1.00		
4	VACUUM OF ANALYZER (WITH BEAM GATE OUT UNDER NO LOAD)	E-6Torr	_	1.00		
5	VACUUM OF BEAM LINE (DURING IMPLEMENTATION OF P-RS DUMMY INJECTION)	E-6Torr	1	1.00		
	WHETHER ERROR OCCURRED OR NOT (DURING IMPLEMENTATION OF P-RS DUMMY INJECTION)	_	-	-		
6	VACUUM OF BEAM LINE (DURING IMPLEMENTATION OF P-RS 30 DUMMY INJECTION)	E-6Torr	1	1.00		
	WHETHER ERROR OCCURRED OR NOT (DURING IMPLEMENTATION OF P-RS DUMMY INJECTION)	-	-	-		

RETURN

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SECTION). SECTION).	:Y TO IENT SECTION).		SECTION).	Y TO AN ENGINEER.	REQUENCY. Y TO ENT SECTION).
	STOP A UNIT AND NOTIFY TO (APPARATUS MANAGEMENT SECTION). STOP THE PRODUCT.	STOP A UNIT AND NOTIFY TO (APPARATUS MANAGEMENT SECTION). STOP THE PRODUCT.	STOP A UNIT AND NOTIFY TO (APPARATUS MANAGEMENT SECTION). STOP THE PRODUCT.	STOP A UNIT AND NOTIFY TO AN ENGINEER.	GAS FLOW THE ERROR OCCURS FREQUENCY. STOP A UNIT AND NOTIFY TO ABNORMALITY (APPARATUS MANAGEMENT SECTION).
OF ALARM	VACUUM PRESSURE ABNORMALITY	VACUUM PRESSURE ABNORMALITY	VACUUM PRESSURE ABNORMALITY	CURRENT VALUE ABNORMALITY	GAS FLOW RATE ABNORMALITY
No	01	83	95	10	50
No	A0001	A0001	A0001	A0001	A0001
ALAKM DATA	* * * * * * * * * * * * * * * * * * *	****	* * * * * * * * * * * * * * * * * * *	* * * * * * * * * * * * * * * * * * *	* * * * *
ERROR	FATAL ERROR	FATAL ERROR	FATAL ERROR	FATAL ERROR	ABNORMALITY IN NUMBER OF TIMES
BOX TIME PERIOD	4/1 13:00	4/1 13:15	4/1 13:30	4/1 13:45	4/1 14:30
BOX	Ø	Ø	Ø		

RETURN

G. 25

OCCURRENCE TIME PERIOD	LOT No WAFER No	WAFER No CONTENT OF ALARM	LINE COMMENT INPUT COLUMN
A(A0001 01	VACUUM PRESSURE ABNORMALITY	VACUUM PRESSURE THERE IS NO PROBLEM OF CHECK POINTS OF A VALVE AND VACUUM GAUGE. ABNORMALITY STAFFS AGREE FLOWING PRODUCTS.
)Y	A0001 03	VACUUM PRESSURE ABNORMALITY	VACUUM PRESSURE THERE IS NO PROBLEM OF CHECK POINTS OF A VALVE AND VACUUM GAUGE. ABNORMALITY STAFFS AGREE FLOWING PRODUCTS.
9	A0001 05	VACUUM PRESSURE ABNORMALITY	VACUUM PRESSURE THERE IS NO PROBLEM OF CHECK POINTS OF A VALVE AND VACUUM GAUGE. ABNORMALITY STAFFS AGREE FLOWING PRODUCTS.

INPUT END

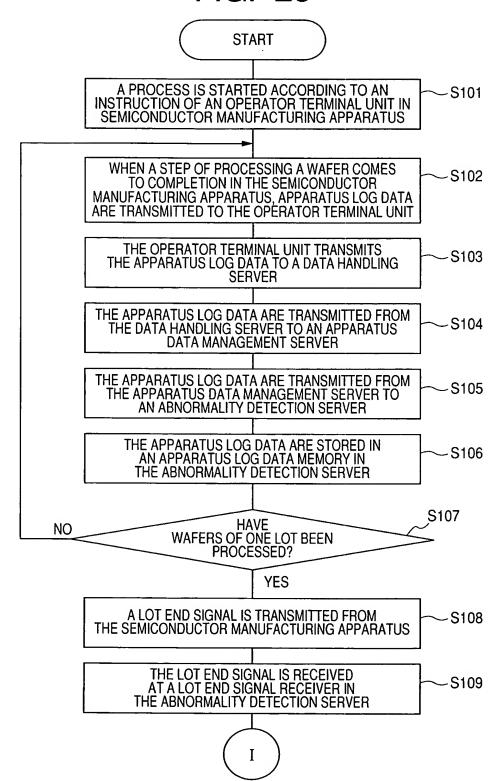
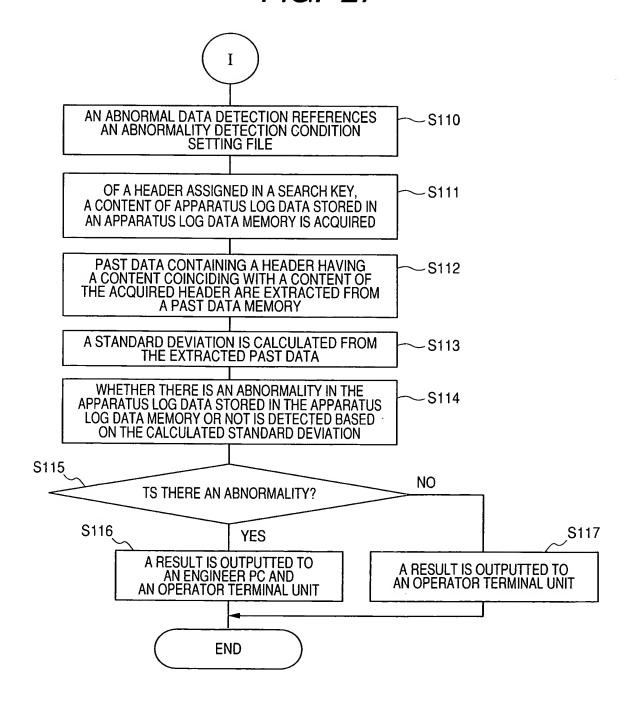


FIG. 27



22 / 27

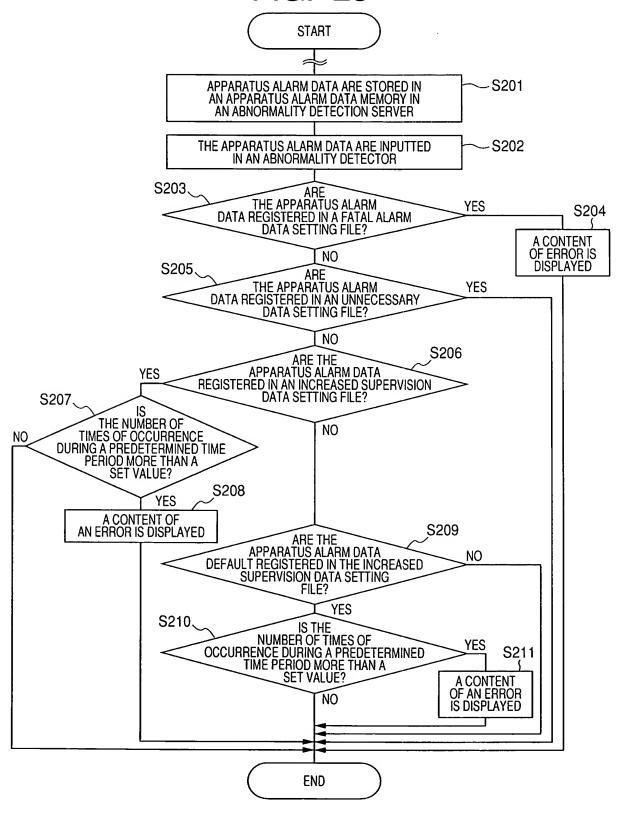


FIG. 29

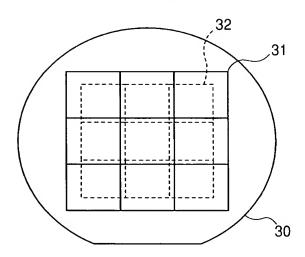


FIG. 30

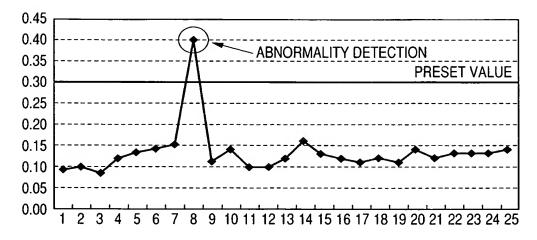
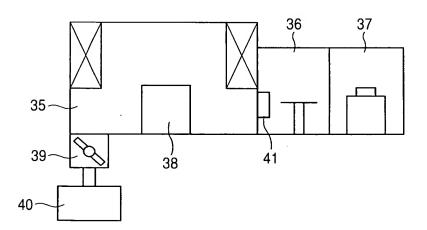
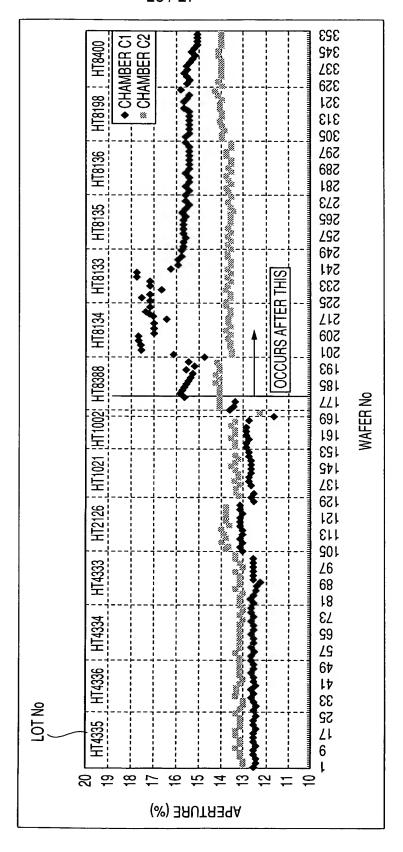


FIG. 31





-1G. 32

FIG. 33

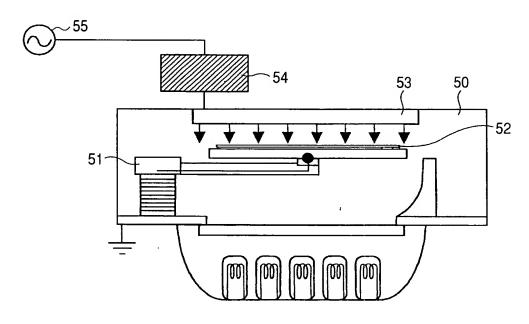


FIG. 34

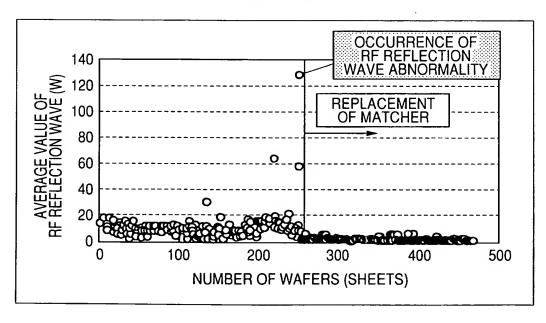


FIG. 35

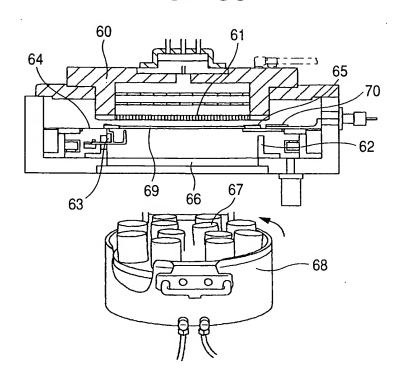


FIG. 36

